

Application/Control No.	Applicant(s)/Patent under Reexamination CHEUNG ET AL.	
10/695,089		
Examiner	Art Unit	
Stephen Kapushoc	1634	

SEARCHED					
Class	Subclass	Date	Examiner		
			-		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

STRATEGY)
DATE	EXMR
1/13/2006	ѕтк
1/13/2006	STK
1/13/2006	STK
	1/13/2006

Jh 1-13-06